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(PTO ASSISTANCE)

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From: <u>mg</u>	Location: <u>IDC</u> FMF FDC	Date: <u>12.19.05</u>
Tracking #: <u>10 676 628</u>		Week Date: <u>07.18.05</u>

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[RUSH] MESSAGE: _____

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Other Reference, on 'line A28', is illegible.

[XRUSH] RESPONSE: _____

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LIST OF PATENTS AND OTHER ITEMS FOR APPLICANT'S
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SERIAL NO.
09/837,829APPLICANT:
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Moise

SB		Jorg, Guttman; Joachim; Huber, Hans-Peter; "Optical Backplanes With Integrated Polymer Waveguides," <i>Journal of Optical Engineering</i> , Vol. 39, No. 3, March 2000
SB	A29	Mueller, Raluca; Pavelescu; and Manea, Elena; "3D Microstructures Integrated With Optical Waveguides and Photodiodes on Silicon," <i>MELECOB 1998 9th Mediterranean Electromechanical Conference Proceedings</i> , Vol. 1; May 18-20, 1998
SB	A30	Namba, Tohru; Uehara, Akihito; et al.; "High-Efficiency Micromirrors and Branched Optical Waveguides on Si Chips," <i>Japanese Journal of Applied Physics, Part 1</i> , Vol. 35, No. 2B, August 21-24, 1995
SB	A31	Oillier, Eric; Chabrol, Claude; et al.; "1 x 8 Micro-Mechanical Switches Based on Moving Waveguides for Optical Fiber Network Switching," <i>2000 IEEE/LEOS International Conference on Optical MEMS</i> , August 21-24, 2000
SB	A32	Oillier, Eric; and Mottier, P.; "Micro-Opto-Electro-Mechanical Systems: Recent Developments and LEIT's Activities," <i>Proceedings of the SPIE - The International Society for Optical Engineering</i> , Vol. 4076, May 22-24, 2000
SB	A33	Shubin, I.; and Wa, P.L.K.; "Electrostatically Actuated 1 x 2 Micro-Mechanical Optic Switch," <i>Electronics Letters</i> , Vol. 37, No. 7; March 29, 2001
SB	A34	Storgaard-Larsen, Torben; "Plasma-Enhanced Chemical Vapor Deposited Silicon Oxynitride Films for Optical Waveguide Bridges for Use in Mechanical Sensors," <i>Journal of the Electromechanical Society</i> , Vol. 144, No. 4, April 1997
SB	A35	Voges, E.; Hoffmann, M.; "FB1 Optical Waveguides on Silicon Combined With Micromechanical Structures," <i>Advanced Applications of Lasers in Materials and Processing; LEOS Summer Optical Meeting, 1996; IEEE, Piscataway, New Jersey, 96TH8154</i>
SB	A36	Yokoyama, S.; Nagata, T.; and Kuroda, Y.; et al.; "Optical Waveguides on Silicon Chips," <i>Journal of Vacuum Science & Technology A</i> , Vol. 13, No. 3, May-June 1995

EXAMINER:

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